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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUJIEDA, Tsukasa**

Group Art Unit: 1711

Serial No.: **10/576,277**

Examiner: **WALTER JR, Robert S.**

Filed: **April 18, 2006**

**P.T.O. Confirmation No.: 9712**

For: **METHOD OF FORMING LUSTER COATING FILM**

**RESPONSE UNDER 37 CFR §1.116**  
**- EXPEDITED RESPONSE -**  
**GROUP ART UNIT 1711**

**MAILSTOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

May 27, 2010

Sir:

In response to the Office Action dated April 28, 2010, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.